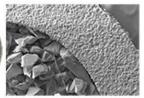
# HIGH PURITY POROUS CERAMIC FLOW COMPONENTS FOR ESCs



# IMPROVE YOUR PROCESS TOOL PRODUCTIVITY WITH EXTENDED ELECTROSTATIC CHUCK LIFETIME AND BETTER FULL WAFER TEMPERATURE UNIFORMITY





Dual density (porous-to-solid) assembly and microstructure

### INCREASED CHUCK DURABILITY

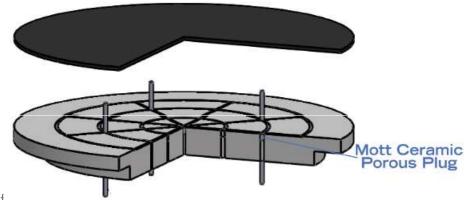
Prevent costly replacement caused by breakdown voltage arcing within the conduit holes by integrating Mott's high porosity ceramic plugs

#### IMPROVE WAFER YIELD

Reduced particles with >99.5% Alumina purity ceramic components and uniform backside gas flow across ESC

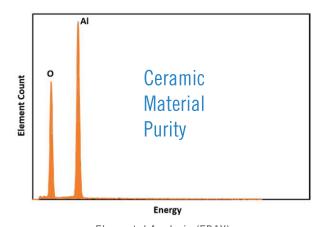
# IMPROVE TEMPERATURE CONTROL

With  ${<}10\%$  part-to-part flow variability, more unif..... He flow across entire backside of wafer



## **SPECIFICATIONS**

Flux	Up to 71.6 SCCM He/cm <sup>2</sup> at 8 Torr
Part-to-Part Variability	<10% at 3-sigma
Material Purity	≥99.5% Alumina
Pore Size	1 μm - 80 μm (tailored for use case)



Elemental Analysis (EDAX)